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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. ONO, et al

Serial No.: 10/754,594

Filed: January 12, 2004

Title: SURFACE PROCESSING METHOD OF A SPECIMEN AND SURFACE PROCESSING APPARATUS OF THE SPECIMEN

Group: 1765

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 29, 2004

Sir:

Attached hereto is the Official Filing Receipt for the above-identified application, wherein it is noted that the ninth inventor in the Applicant(s) data to be incorrect.

Accordingly, it is respectfully requested that a corrected filing receipt be issued indicating that the ninth inventor in the Applicant(s) data to be --**Tatsumi Mizutani, Tokyo JAPAN**-- instead of Tatsumi Mizutani, Tokyo, JAPAN.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



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Registration No.: 22,466

MK/rr
Attachments



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MK

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/754,594	01/12/2004	1765	770	520.37552CC2	12	4	1

020457
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CONFIRMATION NO. 8013
FILING RECEIPT



OC000000013780064

Date Mailed: 09/10/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Power of Attorney: None

Domestic Priority data as claimed by applicant

This application is a CON of 10/135,516 05/01/2002 PAT 6,677,244
which is a CON of 09/393,893 09/10/1999 PAT 6,492,277

Foreign Applications

JAPAN 10-258599 09/11/1998
JAPAN 10-256926 09/10/1998



If Required, Foreign Filing License Granted: 04/15/2004

The number of your priority application, to be used for filing abroad under the Paris Convention is, **US10/754,594**

Projected Publication Date: 12/23/2004

Non-Publication Request: No

Early Publication Request: No

Title

Surface processing method of a specimen and surface processing apparatus of the specimen

Preliminary Class

438

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Title 37, Code of Federal Regulations, 5.11 & 5.15**

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